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PATENT APPLICATION

HE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Masanori UEDA et al.

Confirmation No.: 4124

Serial No: 10/812,362

Group Art Unit: 3663

Filed: March 30, 2004

Docket No. 025720-00030

For: SURFACE ACOUSTIC WAVE DEVICE AND METHOD OF FABRICATING

THE SAME

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents

P.O. Box 1450

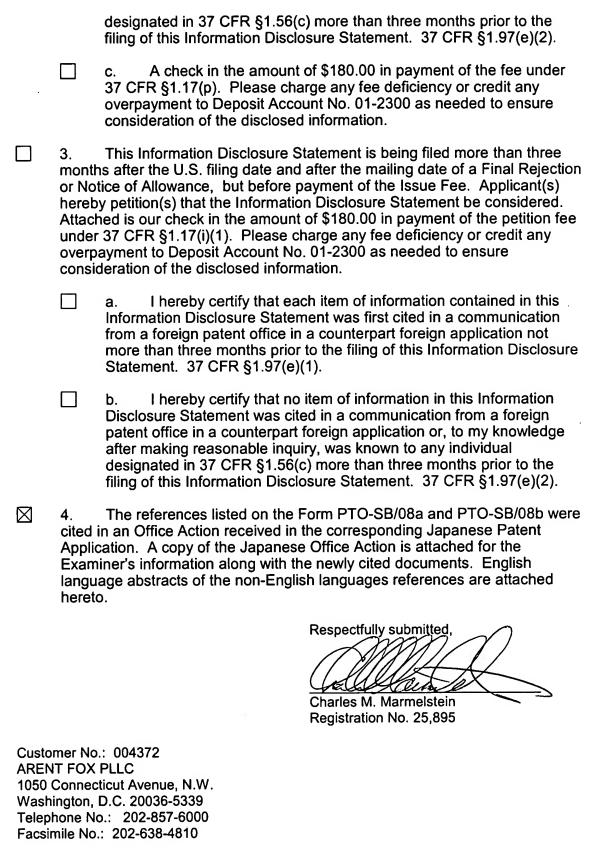
Date: November 15, 2005

Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the information item(s) listed on the attached PTO-SB/08a and PTO-SB/08b. Unless otherwise indicated herein, one copy of each item(s) is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the item(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

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Enclosures: PTO-SB/08a; Japanese Office Action, References (7)

PTO/SB/08a (08-03)

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Sı	bstitute for form 1449A/PTO)			Complete if Known
	Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT Form PTO/SB/08a	Application Number 10/812,362			
''		=	Filing Date	March 30, 2004	
S				First Named Inventor	Masanori UEDA et al.
	Form PTO/S	SB/08a		Art Unit	3663
			Examiner Name		
Sheet	1	of	1	Attorney Docket Number	025720-00030

U.S. PATENT DOCUMENTS						
Examination Initials	Cite	Document Number	Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Releva Passages or Relevant Figures Appear
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				FORE	IGN PATENT	DOCUMENTS		
Examiner Initials*	Cite No.1	Foreign Patent Document	Country Code ³	Number ⁴ Kind Code ⁵ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T⁵
		54-014137	JP		02-02-1979	TOKYO SHIBAURA ELECTRIC CO		AB
		6-268473	JP	Α	09-22-1994	NIPPON STEEL CORP		AB
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PTO/SB/08b (08-03)

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Substitute for form 1449B/PTO			Complete if Known			
Substitute for form 1449B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT Form PTO/SB/08b Sheet 1 of 1	Application Number	10/812,362				
				Filing Date	March 30, 2004	
	•			First Named Inventor	Masanori UEDA et al.	
	INFORMATION DISCLOSURE STATEMENT BY APPLICANT Form PTO/SB/08b Application Number 10/812,362 Filing Date March 30, 2004 First Named Inventor Masanori UEDA et al. Art Unit 3663 Examiner Name	3663				
				Examiner Name		
Sheet	1	of	1	Attorney Docket Number	025720-00030	

		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²
0V 1 5 20	N945	Hideki TAKAGI, "Room-Temperature Bonding of Silicon Wafers By Means Of The Surface Activation Method", Report of Mechanical Engineering Laboratory, No. 189, December 2000, 14-pages	
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